

DOCKET NO.: 0039-7684-2SRDDIV/nhd

JAN 09 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

BY RE APPLICATION OF: Hisako AOYAMA, et al.

SERIAL NUMBER: 09/558,053

GROUP: 2823

FILED: April 26, 2000

EXAMINER: MALDONADO, Julio J

FOR: PROCESS FOR FABRICATING A METAL WIRING AND METAL CONTACT IN
A SEMICONDUCTOR DEVICE

REQUEST TO CORRECT TITLE OF INVENTION

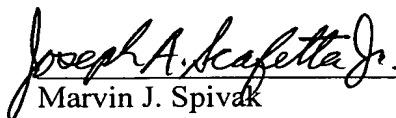
MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request
correction of your records to reflect the correct title of the invention. The title of the
invention should read as follows: **PROCESS FOR FABRICATING A METAL WIRING
AND METAL CONTACT IN A SEMICONDUCTOR DEVICE.**

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

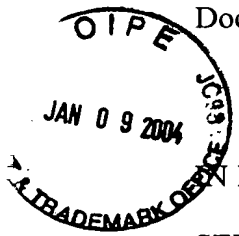


Marvin J. Spivak
Attorney of Record
Registration No. 24,913
Joseph A. Scafetta, Jr.
Registration No. 26,803

Customer Number
22850

Tel.: (703) 413-3000
Fax: (703) 413-2220
(OSMMN 08/03)

Docket No.: 0039-7684-2SRDDIV/nhd



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RE APPLICATION OF: Hisako AOYAMA, et al.

SERIAL NUMBER: 09/558,053

GROUP: 2823

FILED: April 26, 2000

EXAMINER: MALDONADO, Julio J

FOR: PROCESS FOR FABRICATING A METAL WIRING AND METAL CONTACT IN
A SEMICONDUCTOR DEVICE

REQUEST TO CORRECT FIRST INVENTOR'S NAME

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

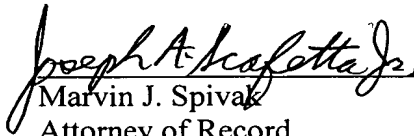
SIR:

In the matter of the above-identified application, we hereby request correction of your records to reflect the correct spelling of the first inventor's name.

The first inventor's name should be: **Hisako AOYAMA, et al.**

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


Marvin J. Spivak

Attorney of Record
Registration No. 24,913
Joseph A. Scafetta, Jr.
Registration No. 26,803

Customer Number
22850

Tel.: (703) 413-3000
Fax: (703) 413-2220
(OSMMN 08/03)

I:\USER\NHDER\NOA\FIRST INVENTOR'S NAME\0039-7684.DOC



OSMM&N File No. 0039-7684-2SRD DIV

Dept.: E/M

By: EHK/CES/mai

Serial No. 09/558,053

In the matter of the Application of: Hisako AOYAMA, et al.

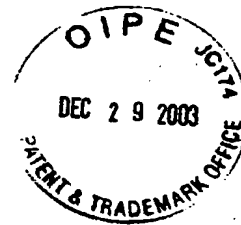
For: **PROCESS FOR FABRICATING A METAL WIRING AND METAL
CONTACT IN A SEMICONDUCTOR DEVICE**

Due Date: N/A

The following has been received in the U.S. Patent Office on the date stamped hereon:

- Dep. Acct. Order Form
- Amendment Cover Letter
- Response under 37 CFR § 1.312

I:\ATTY\CES\00397684.FR_122403.DOC



COPY